



00862.022170

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Haruhiro ONO et al.

Application No.: 09/819,907

Filed: March 29, 2001

For: ELECTRON OPTICAL SYSTEM,
CHARGED-PARTICLE BEAM EXPOSURE
APPARATUS USING THE SAME, AND
DEVICE MANUFACTURING METHOD

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Examiner: Unassigned

Group Art Unit: 2879

March 5, 2003

Commissioner for Patents
Washington, D.C. 20231

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LETTER SUBMITTING CORRECTED PTO-1449 FORM

Sir:

In reviewing the above-identified application, Applicants have noticed an error in the Notice of Art Cited by Applicant (PTO-1449 form) attached to the Information Disclosure Statement filed on January 29, 2003. Specifically, U.S. Patent No. "6,381,702" listed on the PTO-1449 form should read -- 6,381,072 --. Accordingly, Applicants submit herewith a corrected PTO-1449 form.

Applicants request that the information cited in the above-noted Information Disclosure Statement be considered and that a copy of the enclosed corrected PTO-1449 form be initialed and returned indicating that such information has been considered.

No fee under 37 CFR 1.97(c)(2) is believed to be due. Nevertheless, the Commissioner may charge Deposit Account No. 06-1205, should any fee be due for filing this paper.

Applicants' undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

A handwritten signature in dark ink, appearing to read "Steven E. Warner", is written over a horizontal line.

Attorney for Applicants
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